High-Frequency, Low Power Consumption MEMS Relay

Advantest's high-frequency MEMS relay utilizes piezoelectric actuation to achieve low power consumption and high reliability. Via Advantest's proprietary deposition technology, the relay features a piezoelectric film only 1 micron thick, making low actuation voltage possible. The relay also has high reliability, using contact-point control technology honed in Advantest's semiconductor testing equipment, and it can handle up to 20 GHz high-frequency transmission, using Advantest's high-frequency measurement technology.



MEMS Relay Applications

Semiconductor Testing Equipment, High-Speed Communications Devices, High-Frequency Measurement Equipment

MEMS R&D & Production

- R&D Centers : Advantest Gunma R&D Center Advantest Laboratories (Sendai) Brought to Practicality Under the Guidance of Prof. Masayoshi Esashi of Tohoku University
- Production Center: Advantest Component (Sendai) In-House Production of MEMS-Related Products, Compound Semiconductors, and SiPs for High-Frequency Modules

MEMS Probe Pin

Probe pins for probe cards used in wafer test are manufactured using MEMS technology.



Sit Step Si Wafer Actuation Unit Production Si wefer actuation unit (2nd layer) Sit Step Glass Wafer Contact Portion Production (2nd layer) Glass wafer contact portion (2nd layer)

MEMS Relay Production Process



 Frequency Range :
 DC- 20 GHz

 Actuation Voltage :
 12 V

 Contact Form :
 SPDT

 Size (2 types) :
 5.4 x 4.2 x 0.9 mm

 Isolation :
 > 20 dB (to 20 GHz)

 Insertion Loss :
 < 1 dB (to 20 GHz)</td>

 Characteristic Impedance :
 50 Ω

About Advantest

A leading company in measurement and testing, Advantest is involved in industries that require leading-edge testing technology, such as electronics, telecommunications, and semiconductor production. In the semiconductor and component test system business, Advantest offers test systems that support reliability in every semiconductor device category, and holds global market share of roughly 50 %.



17

┢